

PATENT  
8074-1143

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of

Koichi NANIWAE Conf. 9283

Application No. 10/573,492 Group 2892

Filed May 15, 2006 Examiner E. Jones

METHOD OF CLEANING TREATMENT AND METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICE

**AMENDMENT**

Assistant Commissioner for Patents November 23, 2009  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action of August 24, 2009,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of  
claims, which begins on page 2 of this paper.

**Remarks** begin on page 12 of this paper.